

Strips and Pixels progress

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Outline

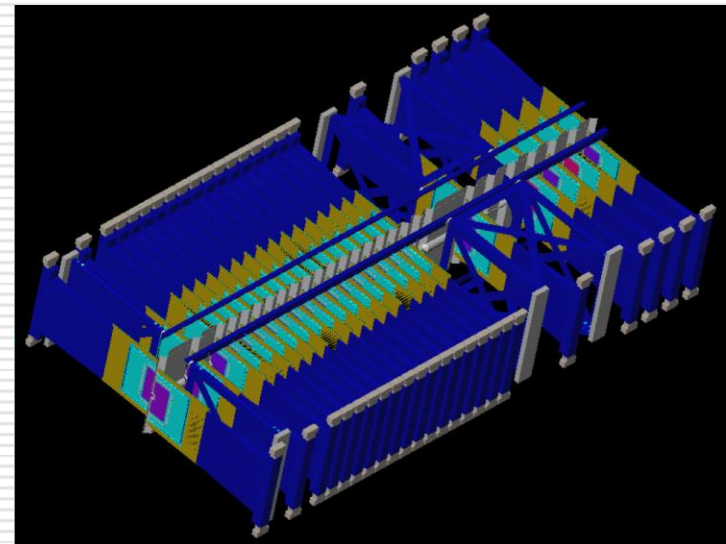
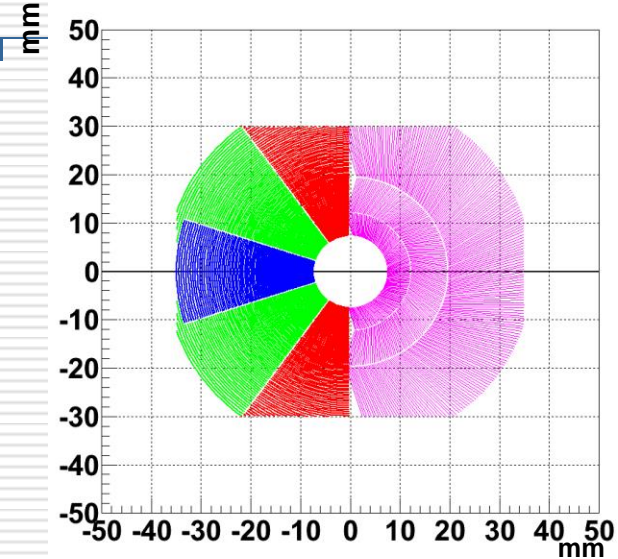
- Strip detector design
- PR01 Strip prototype detector status
- Pixels: thinning status

Strip geometry – Design driving parameters

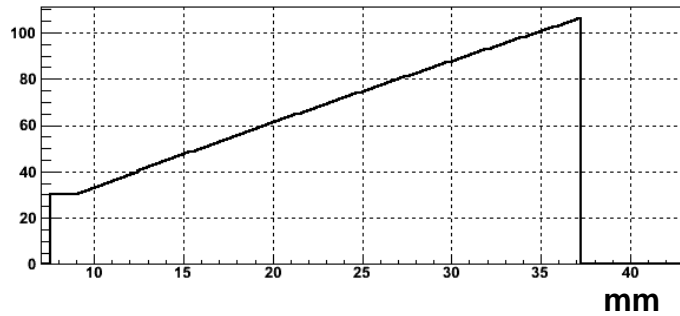
- The current design occupancy at 2×10^{32} is $\sim 0.7\%$. We aim to keep the occupancy $\sim 1\%$, even at a 10 times higher luminosity.
- This is achieved by increasing the number of channels, and decreasing the minimum pitch.
- An ideal minimum pitch would be $25 \mu\text{m}$. In our first prototypes with hamamatsu we will go for $30 \mu\text{m}$.
- The sensor is kept within a rectangle of sides $60 \times 35 \text{ mm}$.
- The material for the simulation is already installed, now the strip pattern should be added.
- It is imperative to match the strip readout to consecutive chip channels for reasons of cm correction. This is addressed in the sensor layout, and an example of a possible routing scheme suggested.
- First presented by Lars Ecklund in:
<http://indico.cern.ch/conferenceDisplay.py?confId=44185>

A possible design

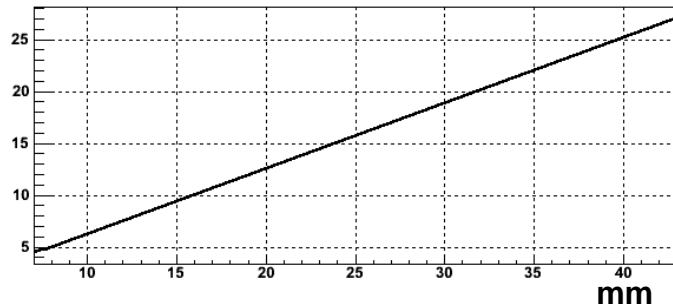
- 30 μm minimum pitch
- 20 chips per sensor
- 3 sectors for ϕ
- Beneficial for the RF-foil as the detector protrudes much less
- R pitch is kept constant for the first 1.5 mm
- Φ pitches are 31/50/61 μm at the boundaries 7.5/12.3/19.8 mm
- R and ϕ occupancies shown on next slide
- Maximum radius in R is 37.2 mm
- XML description already implemented by Warwick in the simulation.



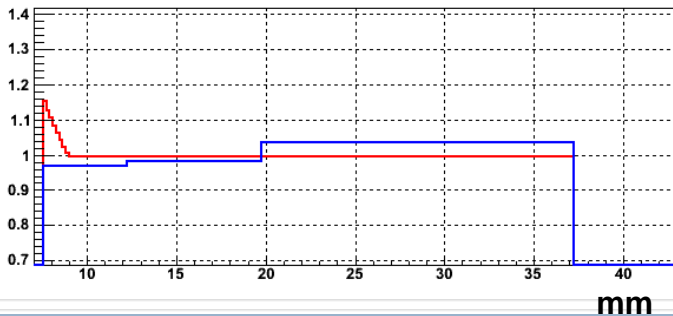
Variation of pitch, strip-length and occupancy as a function of radius



Strip pitch in μm as a function of radius in mm



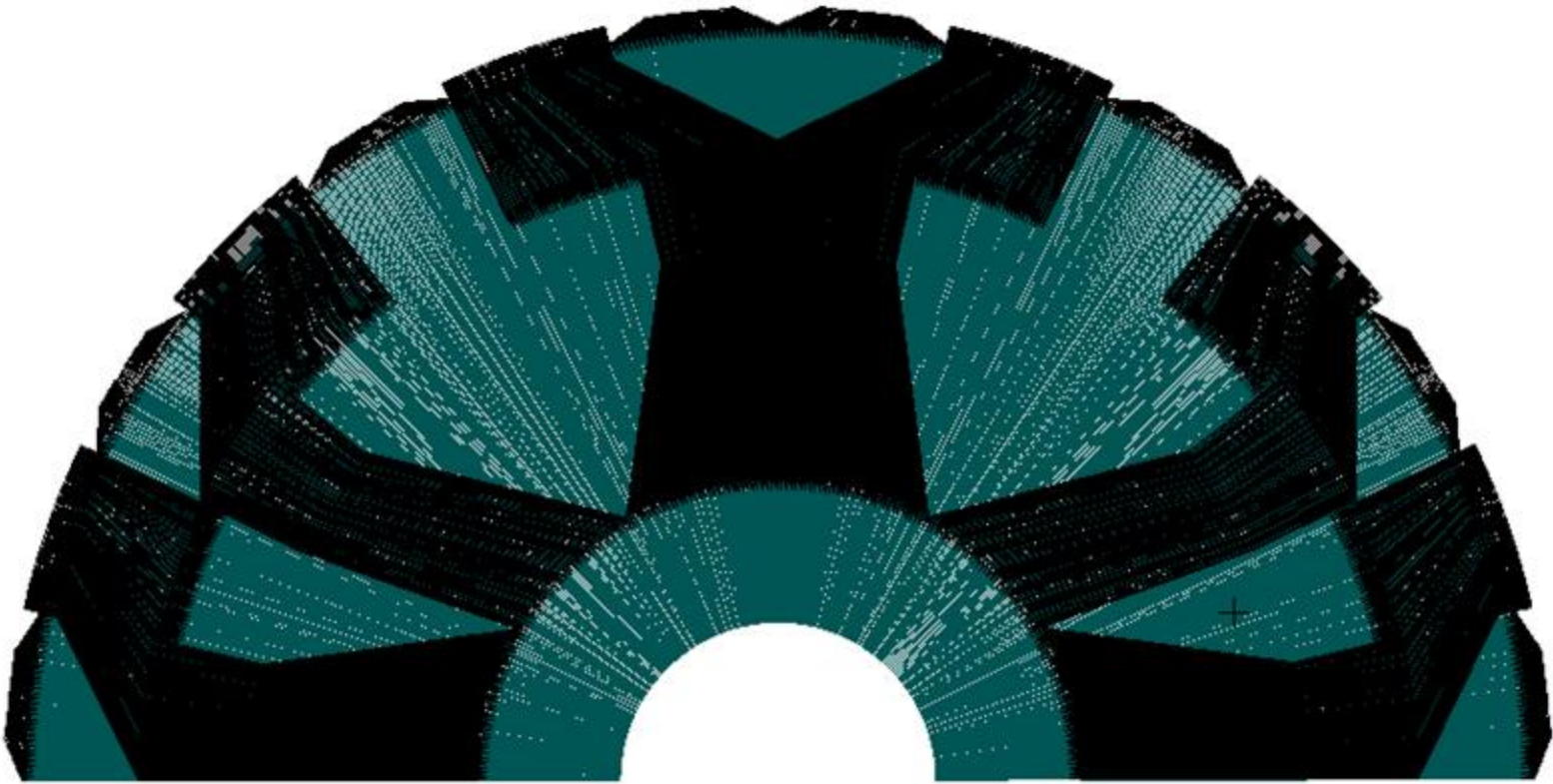
Strip length in the R sensor as a function of radius



Maximum strip occupancy, in percent, for R (red) and Phi (blue) sensors as a function of radius

A possible routing scheme

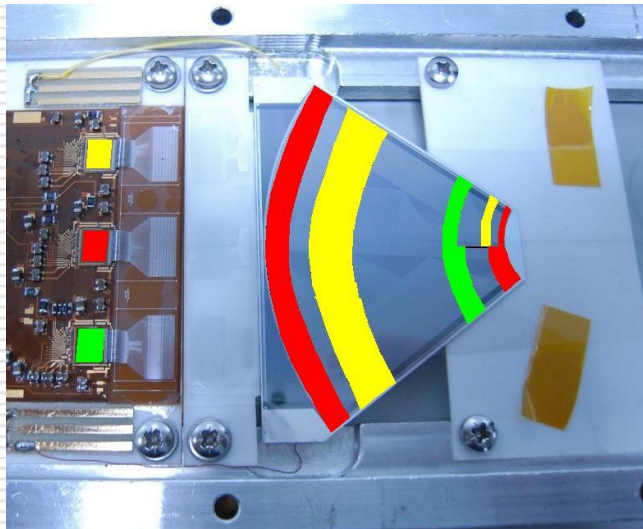
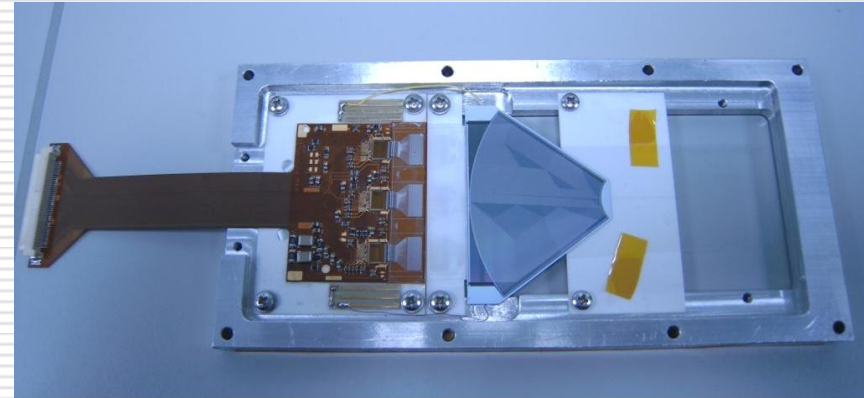
Consecutive strips in a sector in the same chip



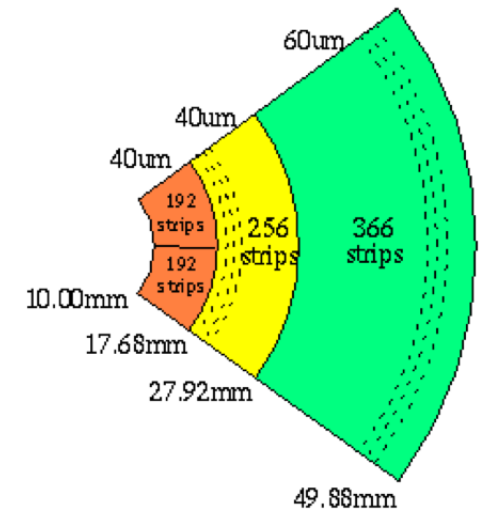
Designed by Lars Ecklund

PR01 strip detector

- Hamamatsu sensor circa 1998
 - (n+n) sensor p-stop
 - 300 μm thickness
- Instrumented with an IT-hybrid (3 Beetle chips)
- the aim is to measure eta and resolution for fine pitch with fast electronics

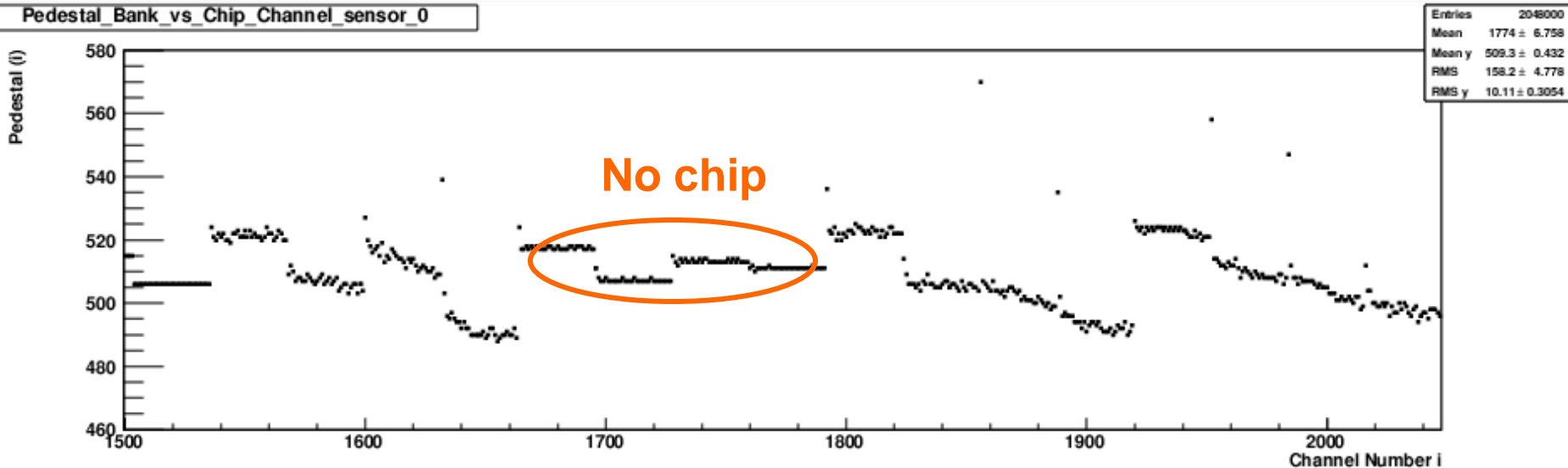


Instrumented strips



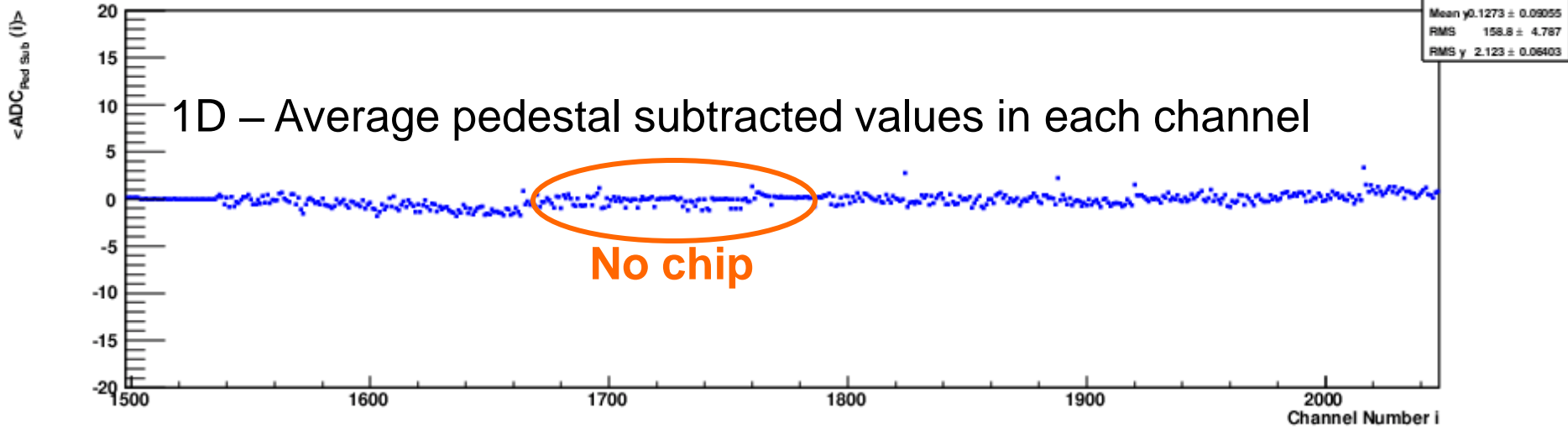
Pedestals

- Stored in the conditions Database (local).
- Obtained from a 10K noise run.
- Values that are subtracted in next runs.
- ADC sampling time not optimized.

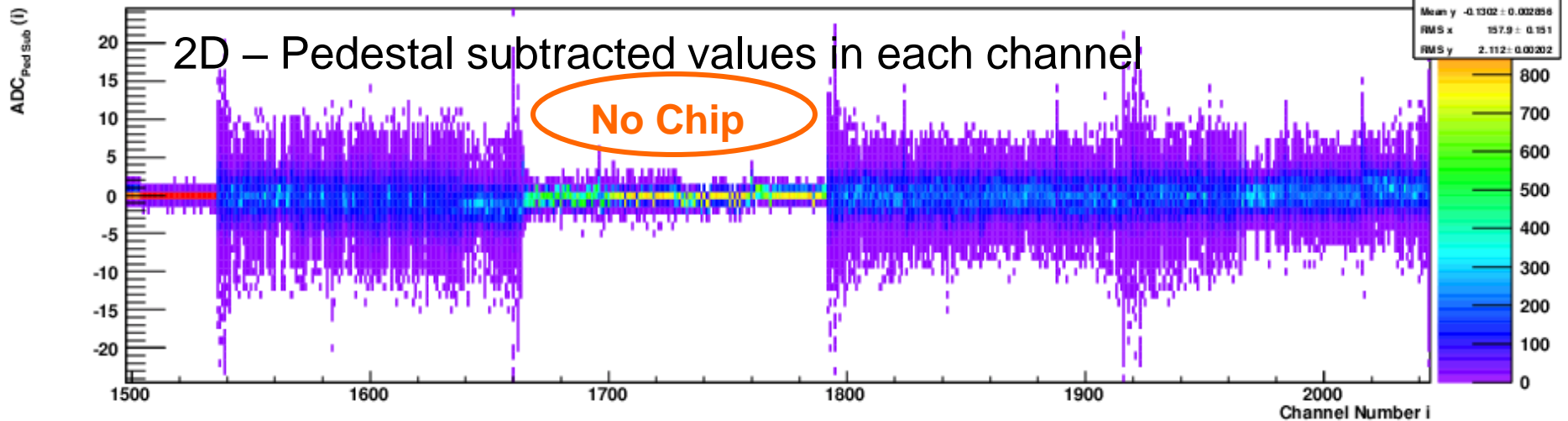


Pedestals

Ped_Sub_ADCs_vs_Chip_Channel_sensor_0Profile



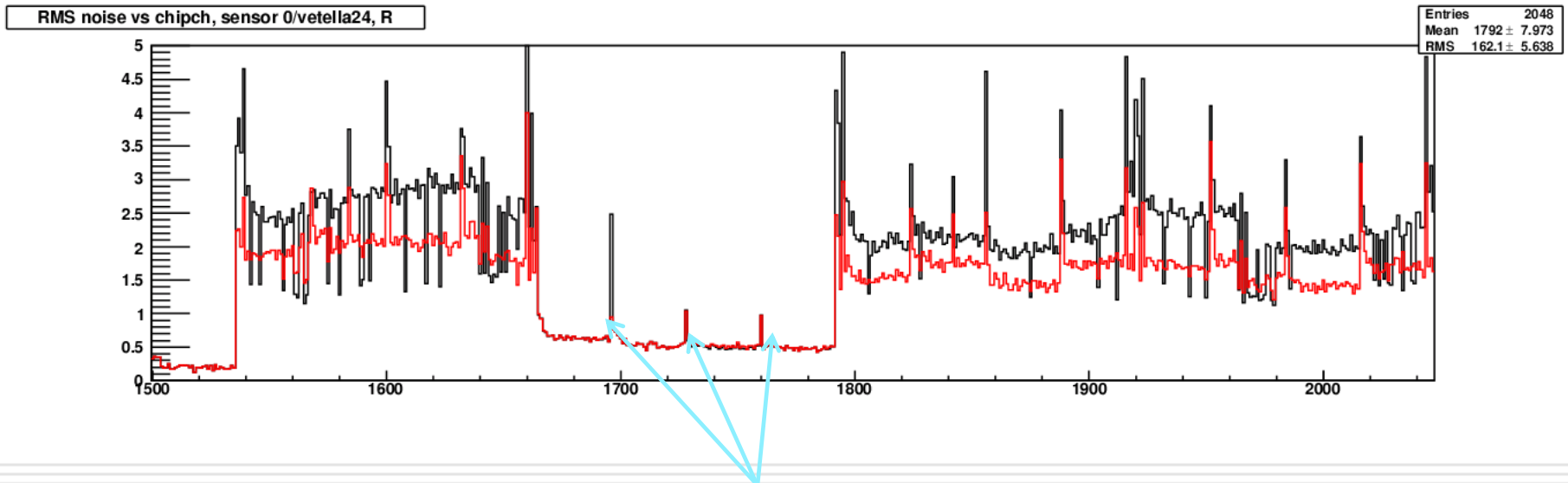
Ped_Sub_ADCs_vs_Chip_Channel_sensor_0



Noise measurements

ADC raw noise

Common mode subtracted noise



No Beetle connected
EM Cross-talk?

Thin Pixel detectors

- Collaboration with CNM to thin 2D-pixel sensor from 300 μm down to (200, 150, 100 μm).
 - Goal: measure the resolution for such thin assemblies
 - Read out with TimePix-like ASIC.
 - Started with p-on-n sensor later
- Run started:
 - Bump bonding tests done on mechanical dummies this week.
 - Bump bonding of real sensors next week.

Photos from run 4967 – Medipix2 on SOI 150 μm

